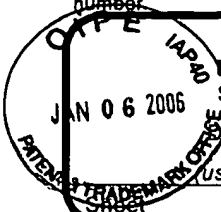


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	<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		<b>Application Number</b>	10/815,517
	Date Submitted: January 6, 2006		<b>Filing Date</b>	4/1/2004
	(use as many sheets as necessary)		<b>First Named Inventor</b>	Hongxing Tang
	1 of 1		<b>Group Art Unit</b>	2856
			<b>Examiner Name</b>	Rose Mary MILLER
			<b>Attorney Docket Number</b>	049411-0266

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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U.S. PATENT APPLICATION DOCUMENTS						
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FOREIGN PATENT DOCUMENTS							
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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.		
RM	A1	BARGATIN et al., "Sensitive detection of nanomechanical motion using piezoresistive signal downmixing," Applied Physics Letters, 86, 133109-1 – 133109-3, 2005.		
RM	A2	JUDY et al., "Magnetic Microactuation of Polysilicon Flexure Structures," IEEE Journal of Microelectromechanical Systems, Vol. 4, No. 4, December 1995, pp. 162-169,		
RM	A3	YI et al., "Magnetic Actuation of Hinged Microstructures," IEEE Journal of Microelectromechanical Systems, Vol. 8, No. 1, March 1999, pp. 10-17.		

Examiner Signature	/Rose Miller/	Date Considered	07/07/2006
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<sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

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